IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


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| In Re Application of | ) | |
| Ji-Guang Zhang | ) | Examiner: |
| Serial No. 10/617,839 | ) | Art Group: |
| Filed: July 11, 2003 | ) | |
| For: SYSTEM & METHOD OF PRODUCING THIN-FILM ELECTROLYTE | ) | |

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner of Patents
Box IDS
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §§ 1.56 and 1.97, counsel for applicant hereby submits information for consideration by the Examiner during the prosecution of the above-identified patent application as listed on the accompanying Form PTO 1449. A copy of the non-patent cited information is enclosed.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Asst. Commissioner of Patents, Box IDS, Washington, D.C. 20231 on this 23 day of October, 2003.

Signature _____
Dorian B. Kennedy

FORM PTO-1449 (Modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO.: 170239-00046
SERIAL NO.:10/617,839
APPLICANT: Ji-Guang Zhang
FILING DATE: 07/11/03
ART GROUP:
EXAMINER:
Sheet 1 of 2



INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(Use several sheets in necessary)

(37 CFR 1.98(b)

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| EXAMINER | DATE CONSIDERED |
|---|---|

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.